

Electronic Acknowledgement Receipt

EFS ID:	1429674
Application Number:	10792323
International Application Number:	
Confirmation Number:	4370
Title of Invention:	Apparatus and method for vaporizing solid precursor for CVD or atomic layer deposition
First Named Inventor/Applicant Name:	Lawrence C. Lei
Customer Number:	44257
Filer:	Keith M. Tackett/Tammi Thomas
Filer Authorized By:	Keith M. Tackett
Attorney Docket Number:	AMAT/5191C1/ISM/CORE/MCVD
Receipt Date:	10-JAN-2007
Filing Date:	03-MAR-2004
Time Stamp:	16:04:53
Application Type:	Utility

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Request for Continued Examination (RCE)	005191C1Y2_RCE_EF.pdf	73087	no	1

Warnings:

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Information:	Total Files Size (in bytes):	73087
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National Stage of an International Application under 35 U.S.C. 371 If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.		